



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: Miwa KOZAWA et al.

Group Art Unit: 1644

Serial No.: 10/629,806

Examiner: Unassigned

Filed: July 30, 2003

Confirmation No.: 2495

For: **RESIST PATTERN THICKENING MATERIAL, PROCESS
FOR FORMING RESIST PATTERN, AND PROCESS FOR
MANUFACTURING SEMICONDUCTOR DEVICE**

Attorney Docket No.: 030923
Customer Number: 38834

**INFORMATION DISCLOSURE STATEMENT
PURSUANT TO 37 CFR 1.97(b)**

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

March 26, 2004

Sir:

Applicants direct the attention of the Patent and Trademark Office to the documents listed on the attached Form PTO-1449. A copy of each listed document is attached.

No fee or certification is required in connection with this Information Disclosure Statement, because it is being submitted prior to the issuance of a first official action on the merits or expiration of the three month period following the filing date or the entry of the national stage of the above-captioned application.

The above information is presented so that the Patent and Trademark Office can, in the first instance, determine any materiality thereof to the claimed invention. Applicants respectfully request that the information be expressly considered during the prosecution of this application and that the documents cited in the attached Form PTO-1449 be made of record therein and appear on the first page of any patent to issue therefrom.

Attorney Docket No.: **030923**

Serial No.: **10/629,806**

March 26, 2004

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The Commissioner is authorized to charge our Deposit Account No. 50-2866 for any fee that is required to effect consideration of this statement.

Respectfully submitted,

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Attachments: USPTO-1449
16 References
European Search Report



INFORMATION
DISCLOSURE
CITATION
PTO-1449

Atty. Docket No. 030923 Serial No. 10/629,806

Applicant(s): Miwa KOZAWA, et al.

Filing Date: July 30, 2003 Group Art Unit:

U.S. PATENT DOCUMENTS

Examiner Initial		Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)
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		U.S. 6,319,853 B1	ISHIBASHI	11/20/2001	438	780	March 29, 2000
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*		06,003,824	1/14/1994	JP	Abstract
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OTHER DOCUMENTS

		European Search Report dated January 29, 2004
Examiner		Date Considered